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SERIAL NUMBER 10/072,073	FILING DATE 02/08/2002 RULE	CLASS 134	GROUP ART UNIT 1746	ATTORNEY DOCKET NO. TI-31619
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APPLICANTS

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 Kazutaka Nakayama, Hayami-gun, JAPAN;

** CONTINUING DATA ***** *MC (NONE)*

** FOREIGN APPLICATIONS ***** *MC (Verified)*

JAPAN 2001-032017 02/08/2001

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 03/07/2002

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 2	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 1
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verifier and Acknowledged <i>mc</i> Examiner's Signature <i>mc</i> Initials				

ADDRESS

23494

TITLE

Method for removing particles on semiconductor wafers

FILING FEE RECEIVED 870	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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